

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Robert Z. Bachrach et al.

SERIAL NO.: Not yet assigned

FILED: September 30, 2003

FOR: METHOD OF CHEMICAL-MECHANICAL-JET
ETCHING OF SEMICONDUCTOR STRUCTURES

§ GROUP ART UNIT: 1763
§ (Parent Application)
§
§ EXAMINER: S. MacArthur
§ (Parent Application)
§
§ Attorney Docket No.:
§ AM-5609.D1

Date: September 30, 2003

PRELIMINARY AMENDMENT "B"

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450


Sir:

This Preliminary Amendment "A" accompanies a divisional application of U.S. Application
Serial No. 09/932,396, filed August 17, 2001.

CERTIFICATE OF MAILING UNDER 37 CFR § 1.10

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. EU313733759US in an envelope addressed to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: September 30, 2003


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